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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

8/11/02 Amdt
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In re the Application of

Yoshitaka SASAKI et al.

Application No.: 10/067,863

Filed: February 8, 2002

Docket No.: 111926

For: WIRING PATTERN AND METHOD OF MANUFACTURING THE SAME AND
THIN FILM MAGNETIC HEAD AND METHOD OF MANUFACTURING THE
SAME

PRELIMINARY AMENDMENT

Director of the U.S. Patent and Trademark Office
Washington, D. C. 20231

Sir:

Prior to initial examination, please amend the above-identified application as follows:

IN THE SPECIFICATION:

✓ Page 24, delete lines 24-26.

Page 24, lines 4-5, delete current paragraph and insert therefor:

Fig. 9 is a cross sectional and plan view, respectively illustrating the known thin film
magnetic head;

Page 24, lines 16-17, delete current paragraph and insert therefor:

Figs. 22A and 22B are cross sectional views representing a next manufacturing step;

Page 24, lines 18-20, delete current paragraph and insert therefor:

Figs. 23-31 are cross sectional views showing successive steps of an embodiment of
the method of manufacturing a conductive pattern according to the invention; and

Page 24, lines 21-23, delete current paragraph and insert therefor:

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